ABSTRACT OF THE DISCLOSURE

A leadframe (L/F) processing apparatus includes a leadframe loading unit (1) placed along a loading transport passage of a leadframe for supplying a leadframe which has not undergone lead processing, a lead processing unit (2) coupled to the leadframe loading unit and having a plurality of sets of processing presses (41, 42, 43, 44), a leadframe unloading unit (3) coupled to the lead processing unit for removing a leadframe which has undergone the lead processing, and press pitch adjusting means (5) for freely adjusting press pitch (P) of a plurality of sets of processing presses in the direction of the leadframe loading transport passage. The processing apparatus accordingly makes it possible to easily and surely make adjustment with high precision to the pitch of a plurality of sets of processing presses provided to the lead processing unit according to the pitch of works on the leadframe without proficiency in manipulation.